· · · · · · · · · · · · · · · · · · ·	Application No.	Applicant(s)	
Notice of Allowability			
	09/942,014 Examiner	DEWA, ANDREW S. Art Unit	
	Examine	Art offic	
	Lan Vinh	1765	
The MAILING DATE of this communication All claims being allowable, PROSECUTION ON THE MERITI herewith (or previously mailed), a Notice of Allowance (PTOI NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATEN of the Office or upon petition by the applicant. See 37 CFR	S IS (OR REMAINS) CLOSED ir 85) or other appropriate commi IT RIGHTS. This application is s	this application. If not included	uros TUIC
1.   This communication is responsive to Amendment and	remarks filed on 8/7/2003		
2. A The allowed claim(s) is/are 1-18.			
3. The drawings filed on are accepted by the Exal	miner.		
4. Acknowledgment is made of a claim for foreign prior	ty under 35 U.S.C. § 119(a)-(d)	or (f).	
a) ☐ All b) ☐ Some* c) ☐ None of the:			
Certified copies of the priority documents			
2. Certified copies of the priority documents			
<ol><li>Copies of the certified copies of the priorit</li></ol>		d in this national stage application	n from the
International Bureau (PCT Rule 17.2(a	)).		
* Certified copies not received:		·	
<ol> <li>Acknowledgment is made of a claim for domestic prior reference was included in the first sentence of the spe</li> </ol>	cification or in an Application Dat	ta Sheet. 37 CFR 1.78.	specific
(a) ☐ The translation of the foreign language provision	nal application has been received	i.	
<ol> <li>Acknowledgment is made of a claim for domestic prior in the first sentence of the specification or in an Application.</li> </ol>	ation Data Sheet. 37 CFR 1.78.		
Applicant has THREE MONTHS FROM THE "MAILING DATI below. Failure to timely comply will result in ABANDONMEN	of this application. THIS THR	EE-MONTH PERIOD IS NOT EX	TENDABLE.
<ol> <li>A SUBSTITUTE OATH OR DECLARATION must be s INFORMAL PATENT APPLICATION (PTO-152) which</li> </ol>	ubmitted. Note the attached EXA gives reason(s) why the oath or	MINER'S AMENDMENT or NOT declaration is deficient.	ICE OF
<ol> <li>CORRECTED DRAWINGS (as "replacement sheets")</li> <li>(a) \( \subseteq \) including changes required by the Notice of Drafts</li> </ol>	must be submitted. person's Patent Drawing Review	v ( PTO-948) attached	
1) ⊠ hereto or 2) ☐ to Paper No			
(b) ☐ including changes required by the proposed drawi	ng correction filed, which	has been approved by the Exam	niner.
(c) ☐ including changes required by the attached Exami	ner's Amendment / Comment or	in the Office action of Paper No.	
Identifying indicia such as the application number (see 37 Cl each sheet. Replacement sheet(s) should be labeled as such	FR 1.84(c)) should be written on th in the margin according to 37 CFi	e drawings in the front (not the back R 1.121(d).	ck) of
B. ☐ DEPOSIT OF and/or INFORMATION about the diattached Examiner's comment regarding REQUIREMENT FO	eposit of BIOLOGICAL MATE PR THE DEPOSIT OF BIOLOGIC	RIAL must be submitted. Note CAL MATERIAL.	e the
Attachment(s)			
☐ Notice of References Cited (PTO-892)	5☐ Notice of Info	rmal Patent Application (PTO-15	2)
Notice of Draftperson's Patent Drawing Review (PTO-948		nmary (PTO-413), Paper No	
Information Disclosure Statements (PTO-1449 or PTO/SI Paper No	3/08), 7□ Examiner's Ai	mendment/Comment	
Examiner's Comment Regarding Requirement for Deposi of Biological Material	t 8⊠ Examiner's St 9⊡ Other .	atement of Reasons for Allowand	ce

Application/Control Number: 09/942,014

Art Unit: 1765

## Allowable Subject Matter

Claims 1-18 are allowed.

The following is an examiner's statement of reasons for allowance:

Regarding claims 1, 11, the applicants have presented persuasive arguments (page 7-8 of Applicants remarks filed on 8/7/2003) that the cited prior art of record fails to disclose the step of temporarily mounting a structure wafer to a carrier wafer with alignment relative to the plurality of holes in the carrier wafer. The closest cited prior art of Neukerman et al (US 6,445,844) discloses the step of connecting/mounting a structure wafer 162 to a substrate/carrier 212 with alignment relative to the plurality of holes in the substrate 212 without removing the wafer 162 from the substrate 212 (fig. 16b, fig. 16d). The reasons for allowance of claims 7, 17 have been stated in the previous office action (paper 3)

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

## Conclusion

2. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Lan Vinh whose telephone number is 703 305-6302. The examiner can normally be reached on M-F 8;30-5:30 PM.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Nadine Norton can be reached on 703 305-2667. The fax phone number for the organization where this application or proceeding is assigned is 703 872-9310.

Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is 703 308-0661.

November 26, 2003